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FIG.1A

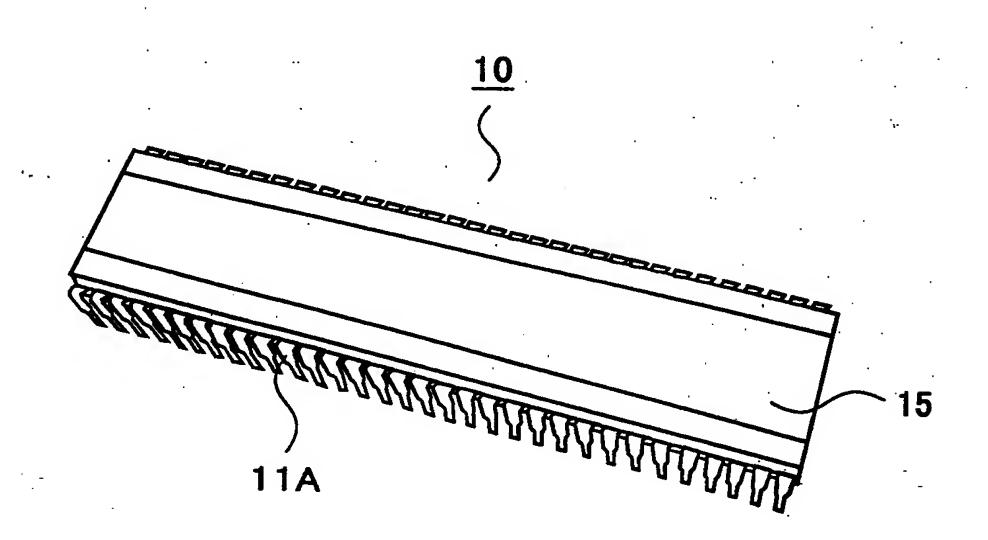
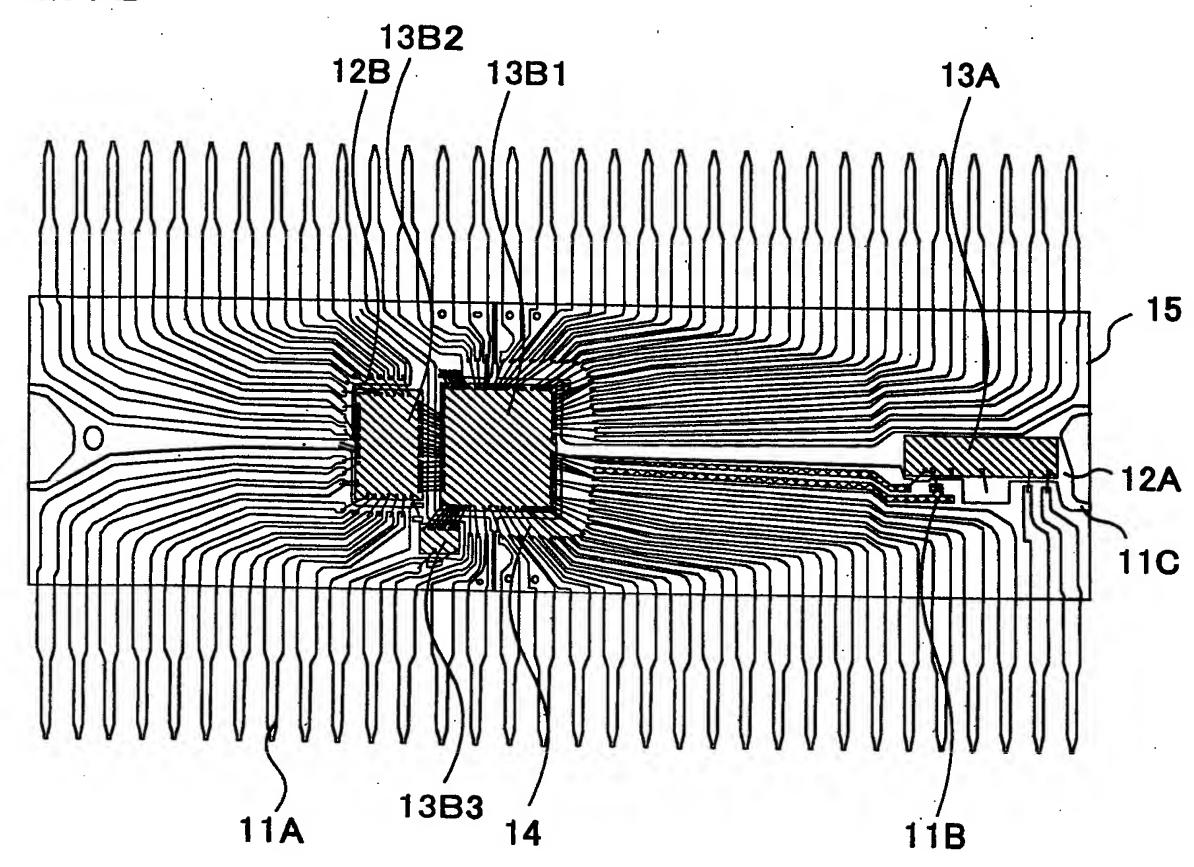


FIG.1B



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FIG.2A

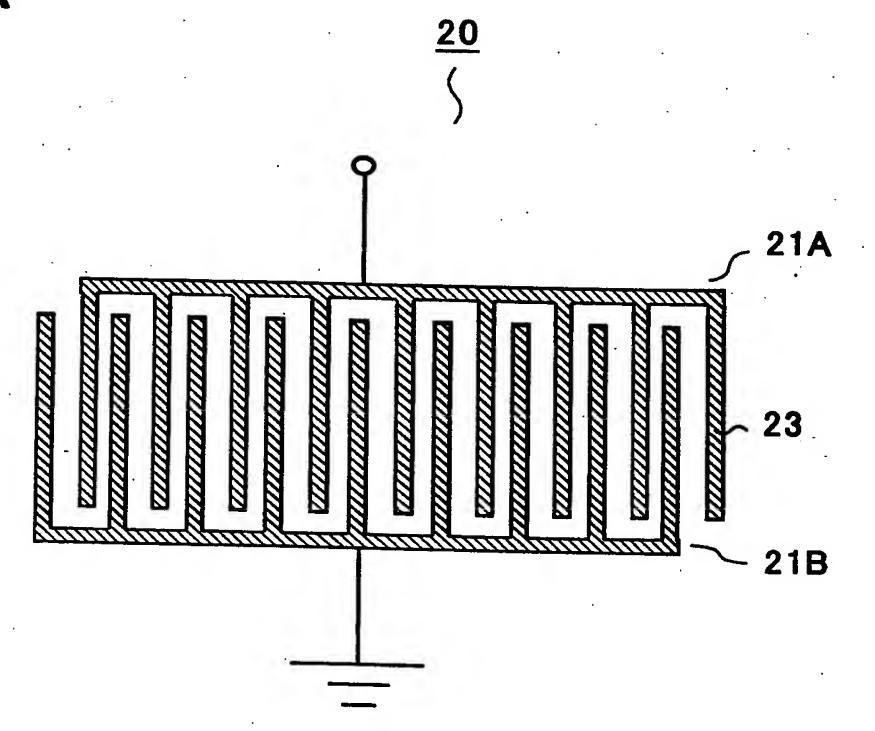
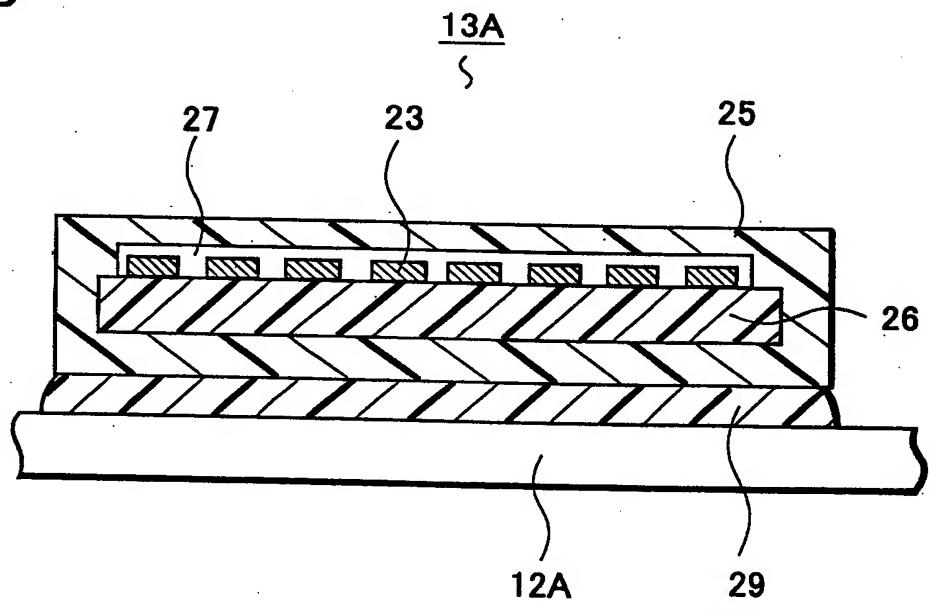


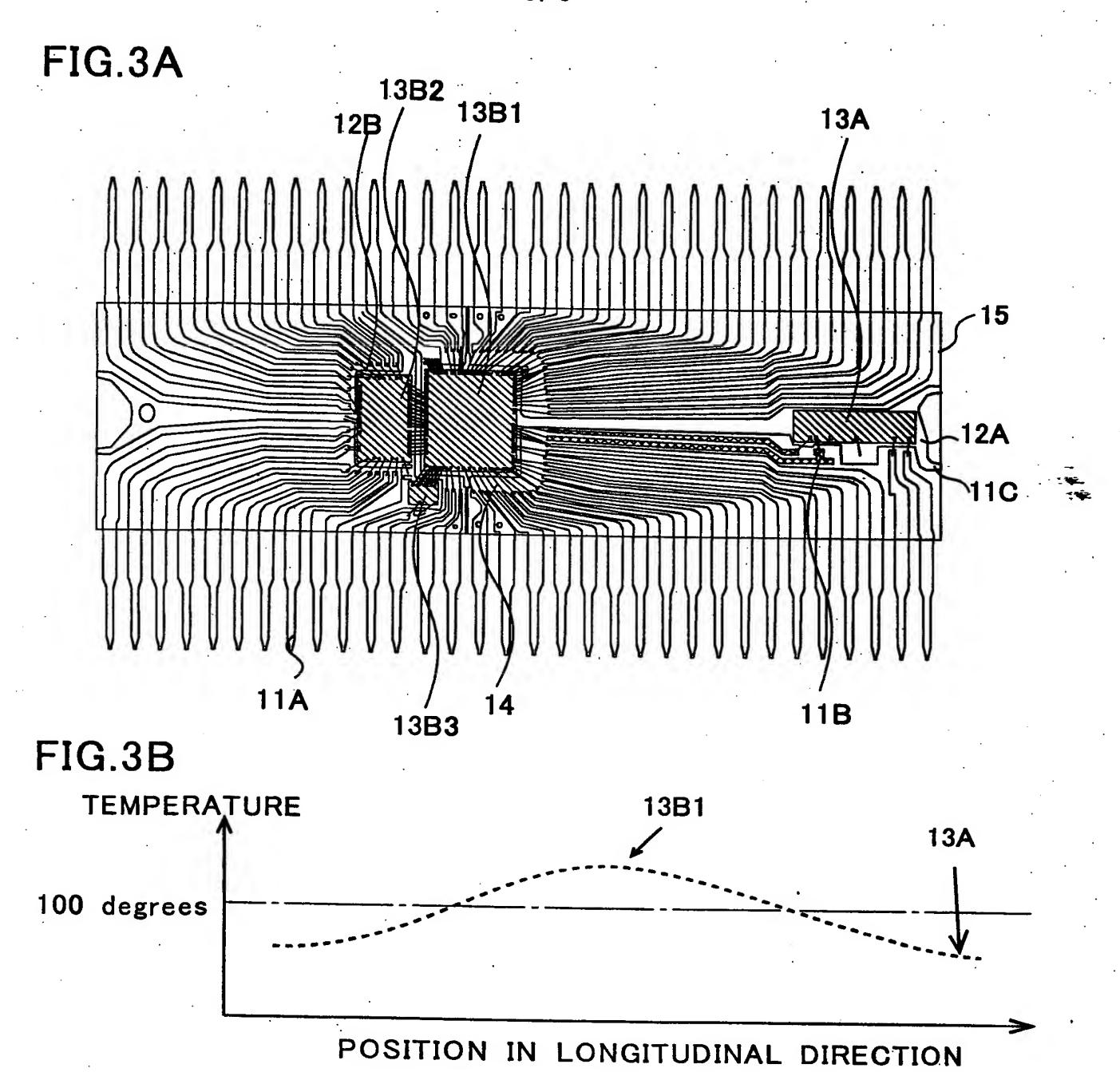
FIG.2B

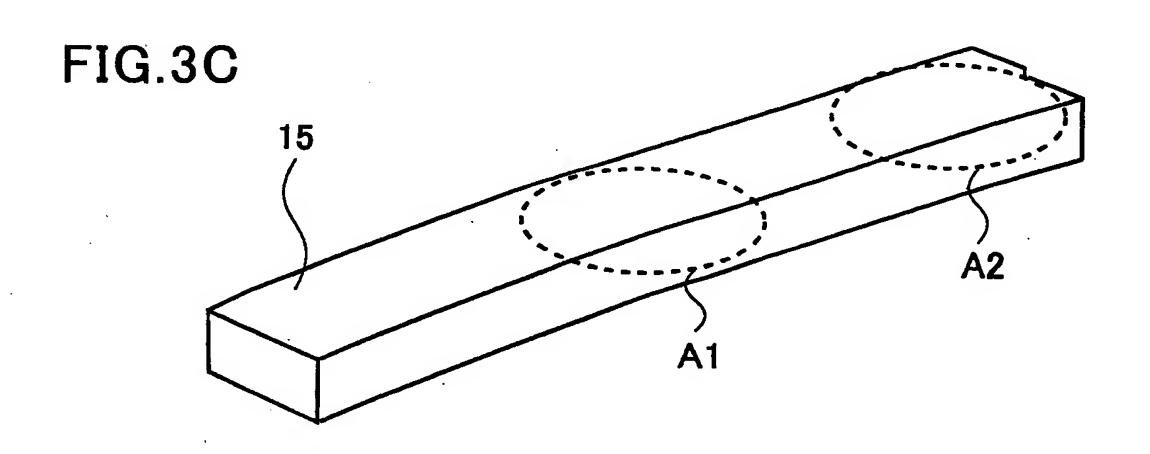


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FIG.4

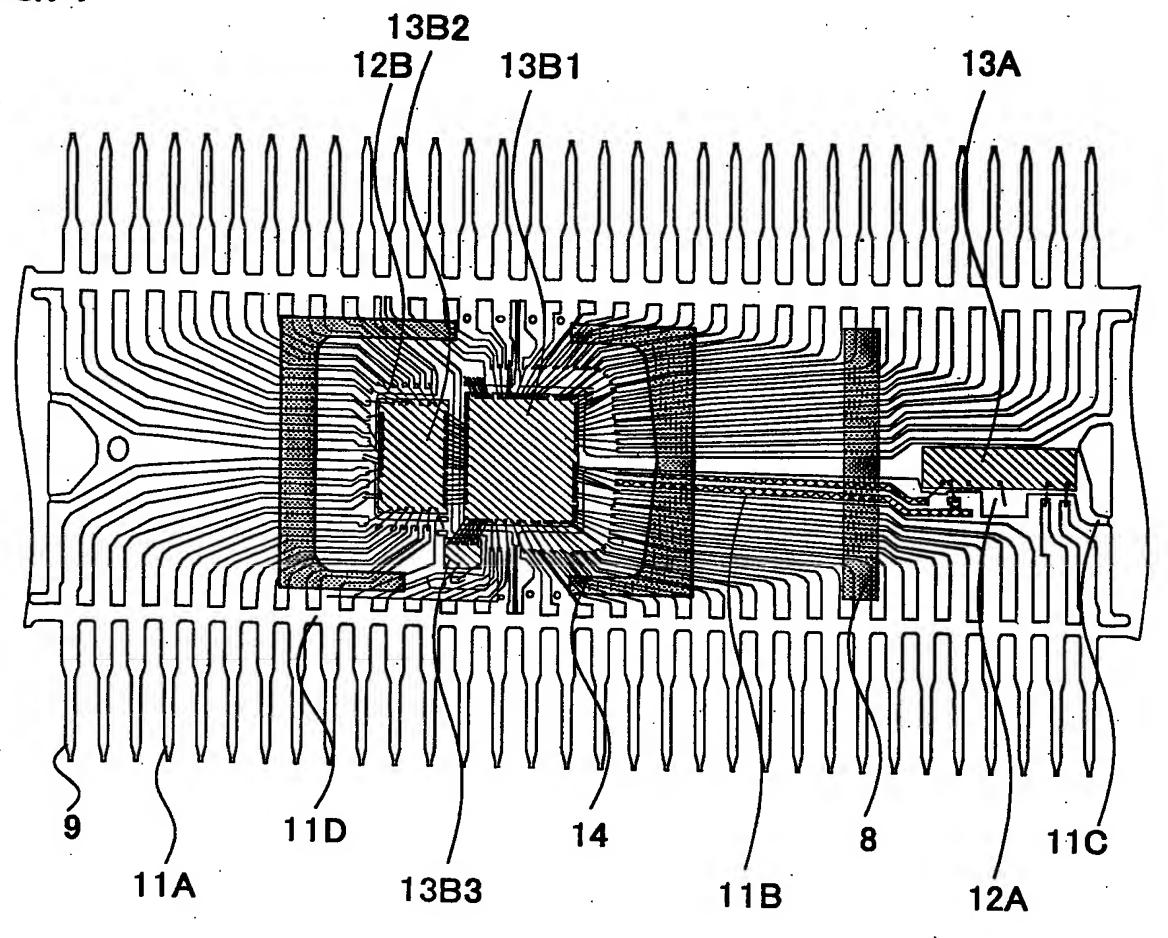


FIG.5A

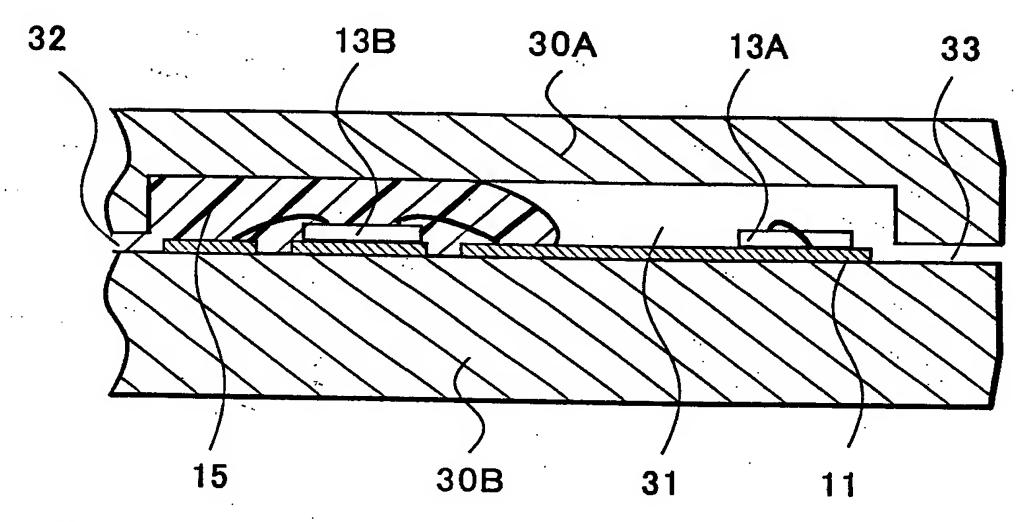


FIG.5B

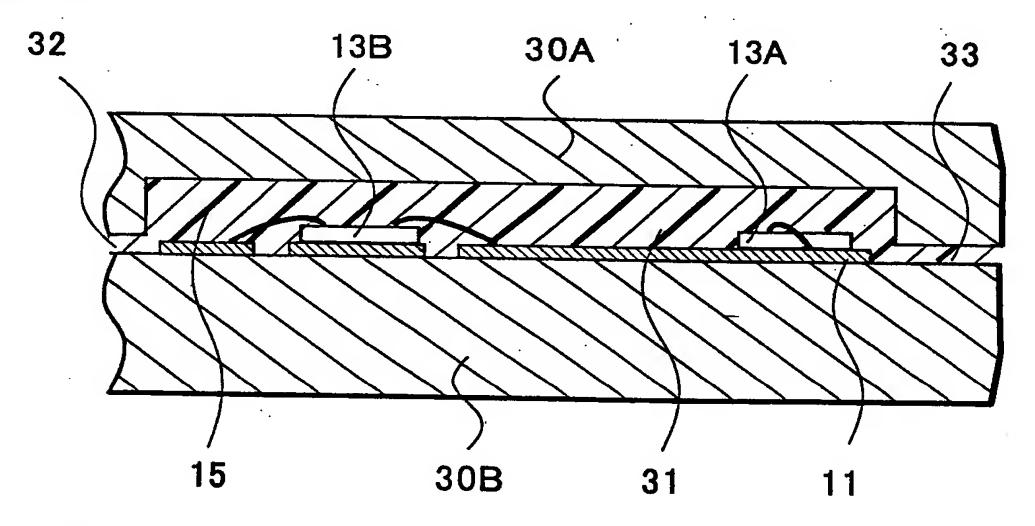


FIG.5C

